

A Novel Plug n Play MEMS-Based DNA Microarray



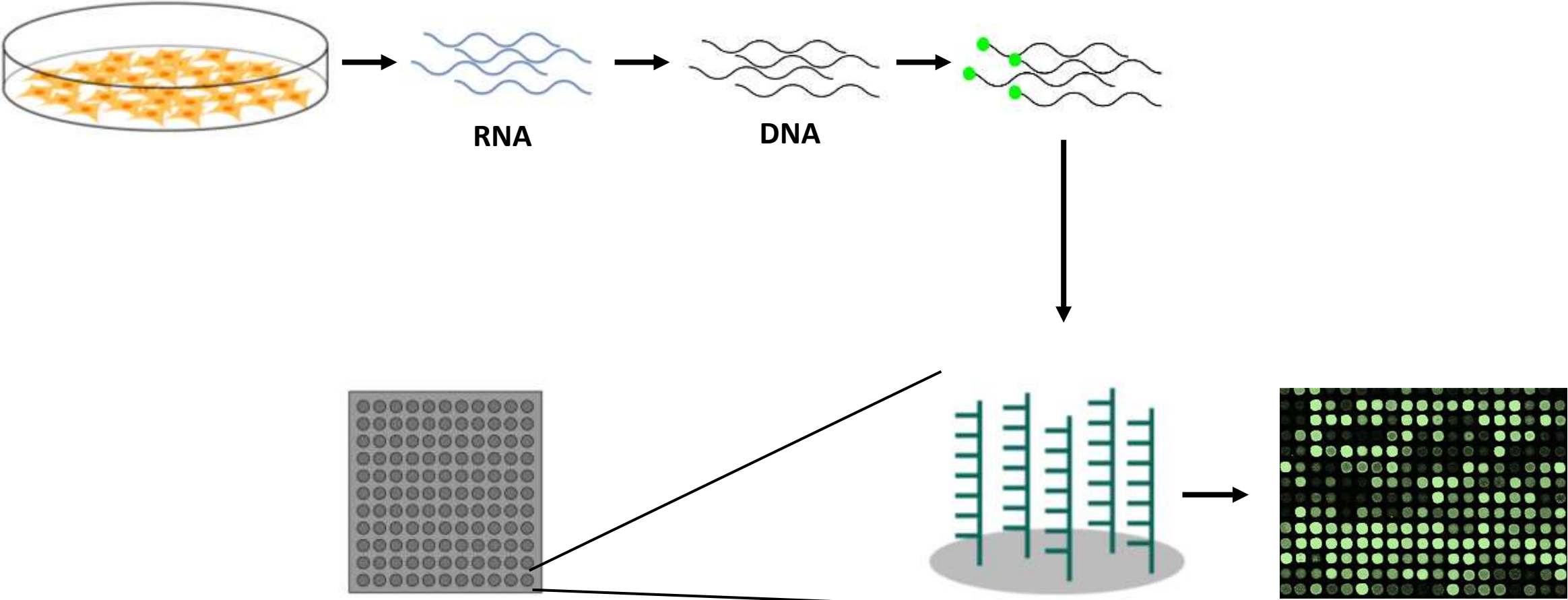
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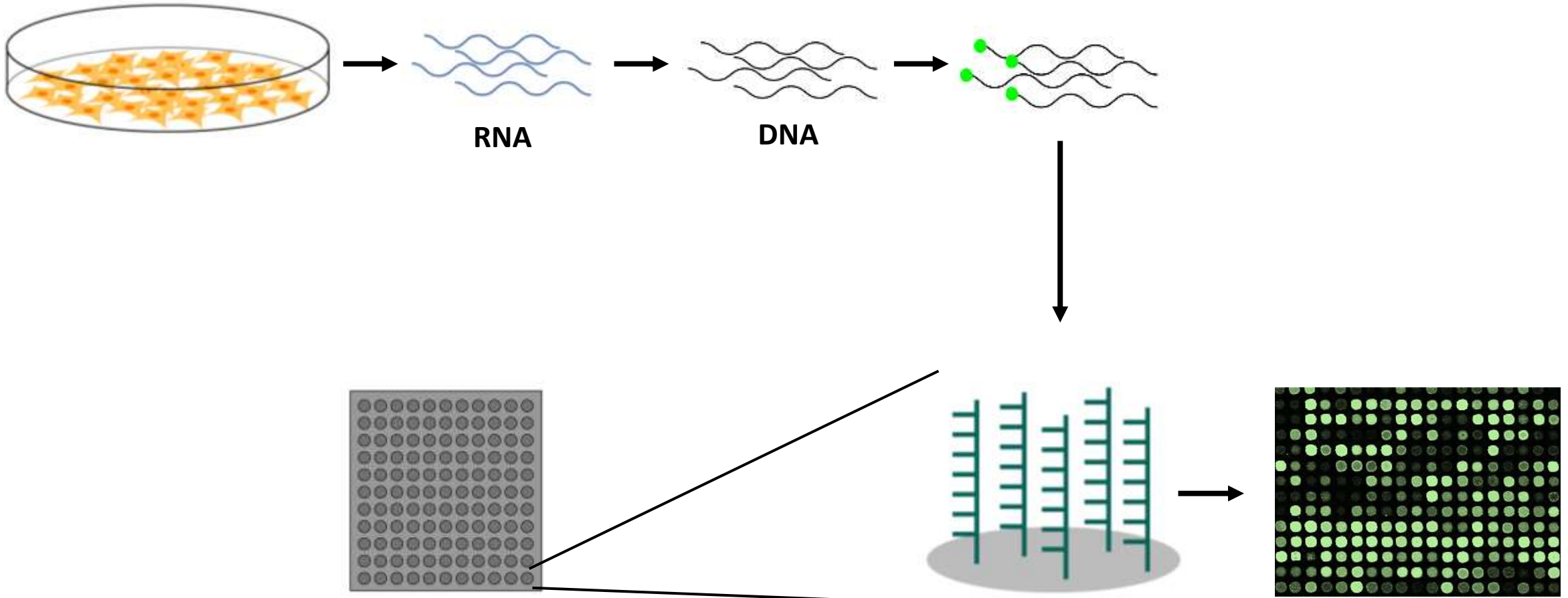
A typical microarray experiment

- Microarrays are used to determine expression levels of **thousands of genes in a sample of cells at once.**

A typical microarray experiment

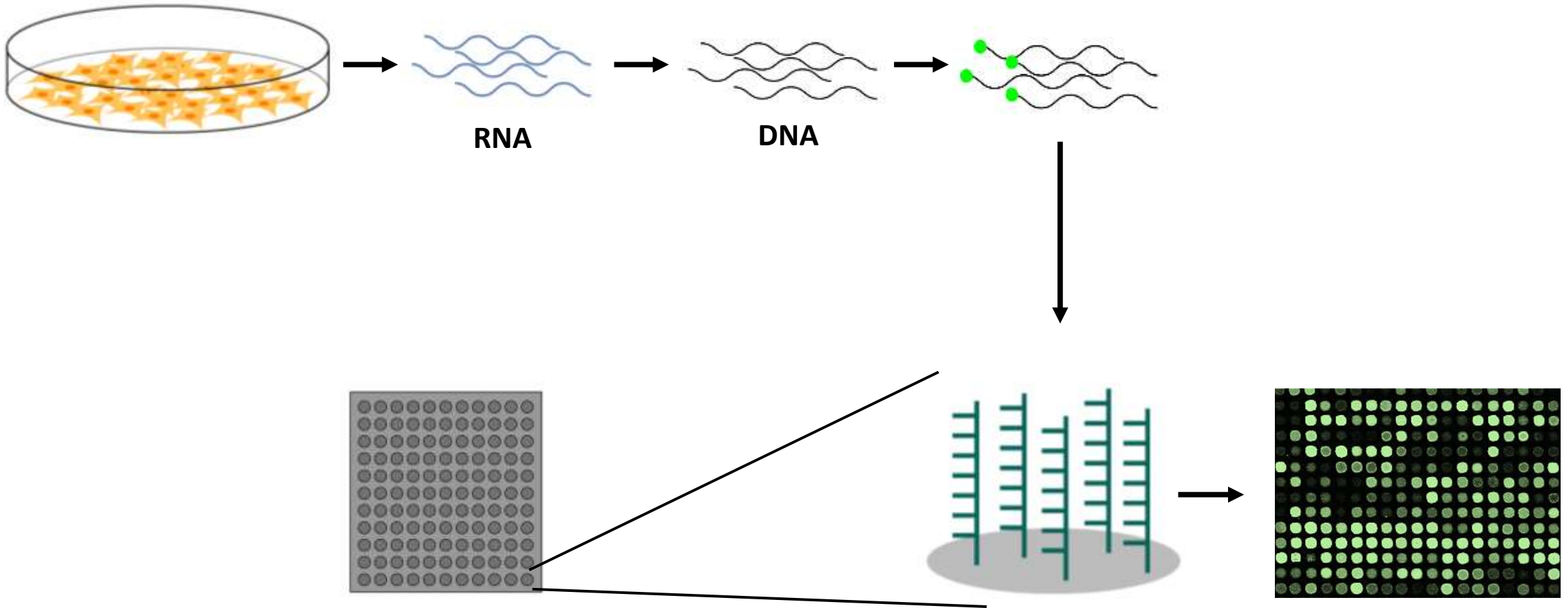


A typical microarray experiment



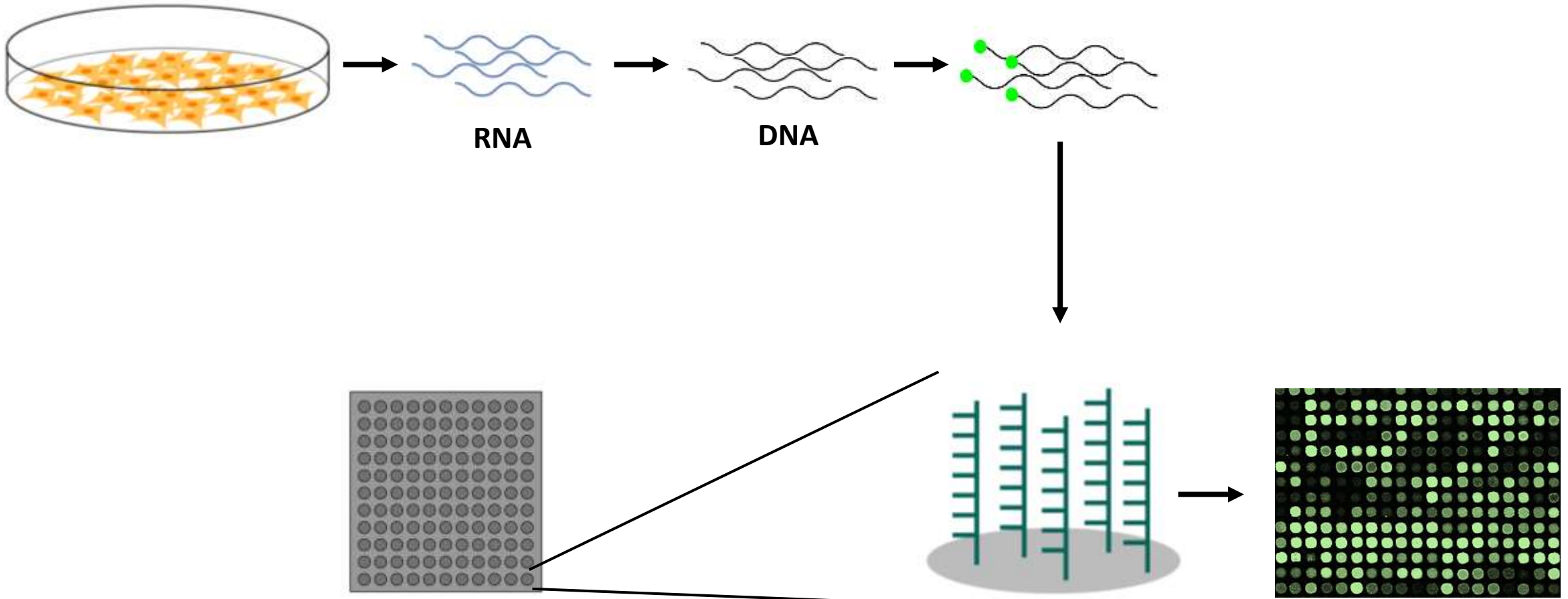
DNA → Fluorescence → Electrical Signal

A typical microarray experiment



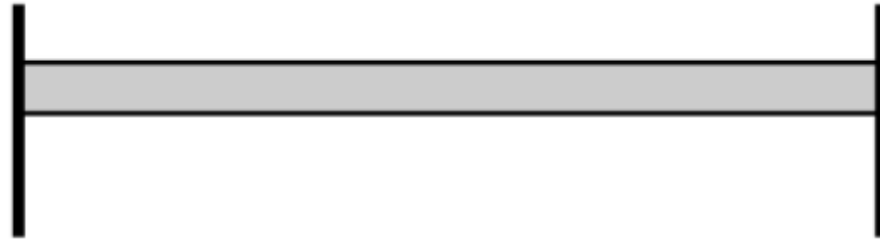
DNA → **Fluorescence** → Electrical Signal

A typical microarray experiment

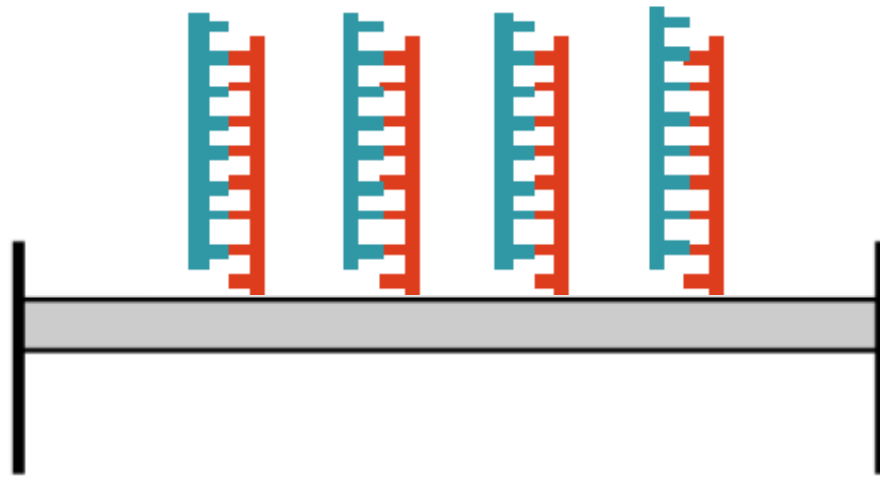


DNA → Electrical Signal

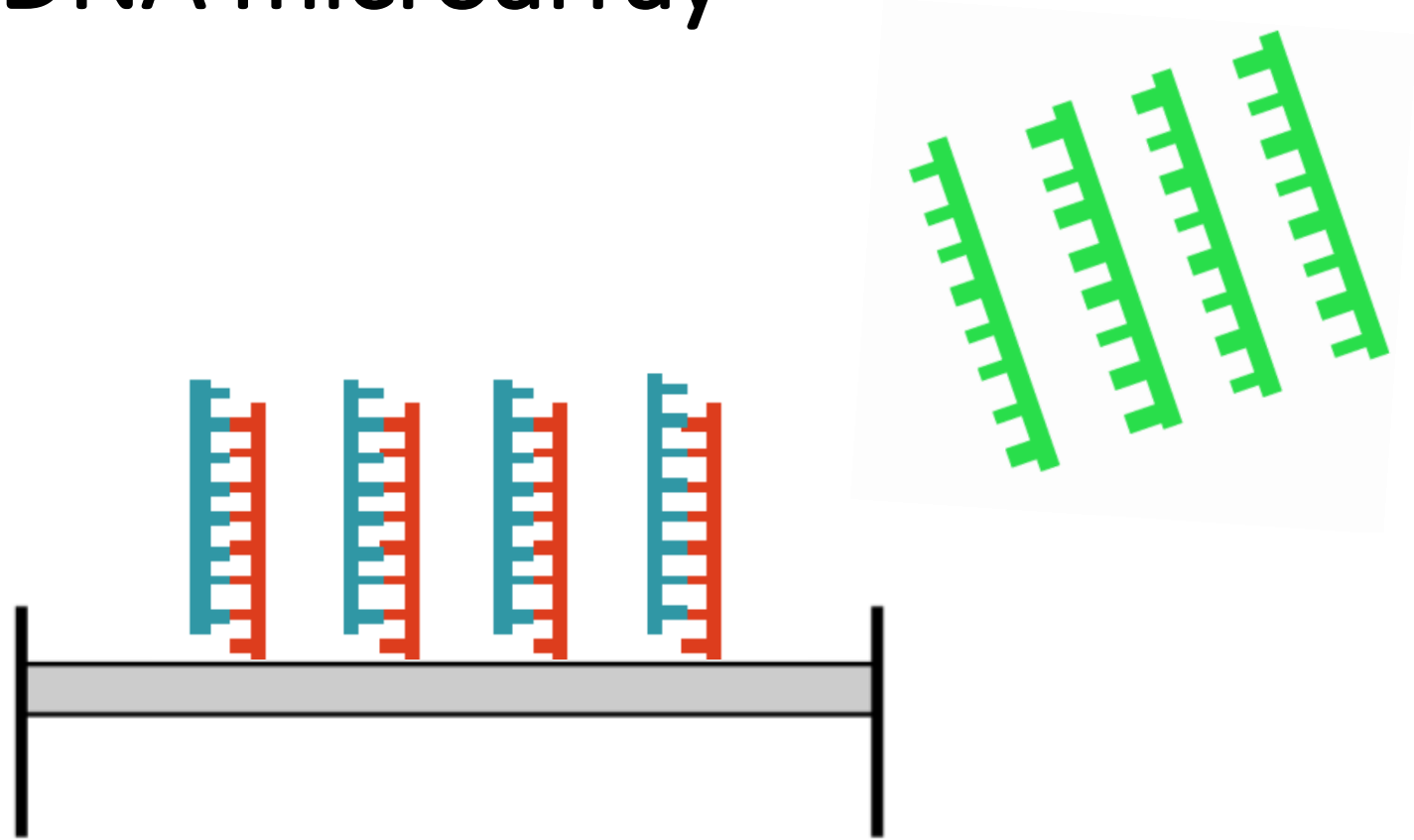
MEMS based DNA microarray



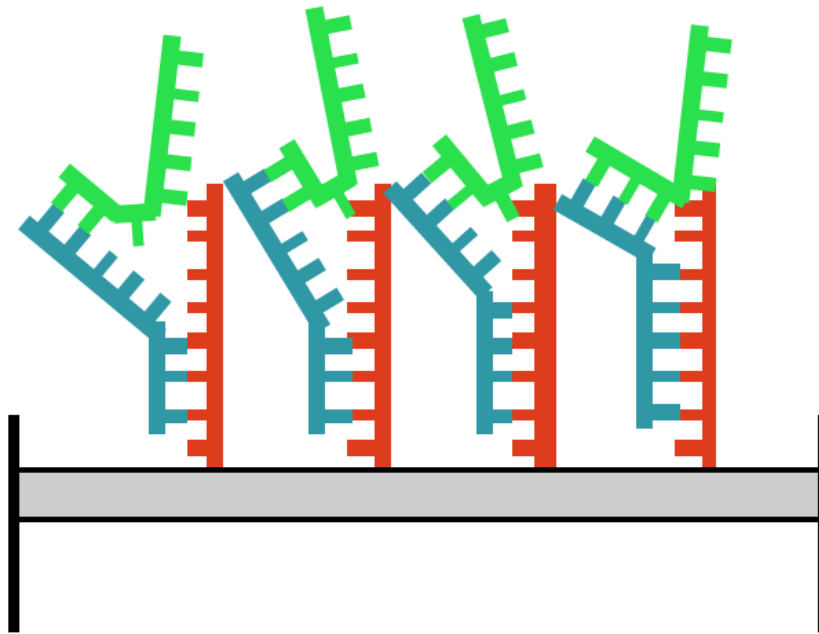
MEMS based DNA microarray



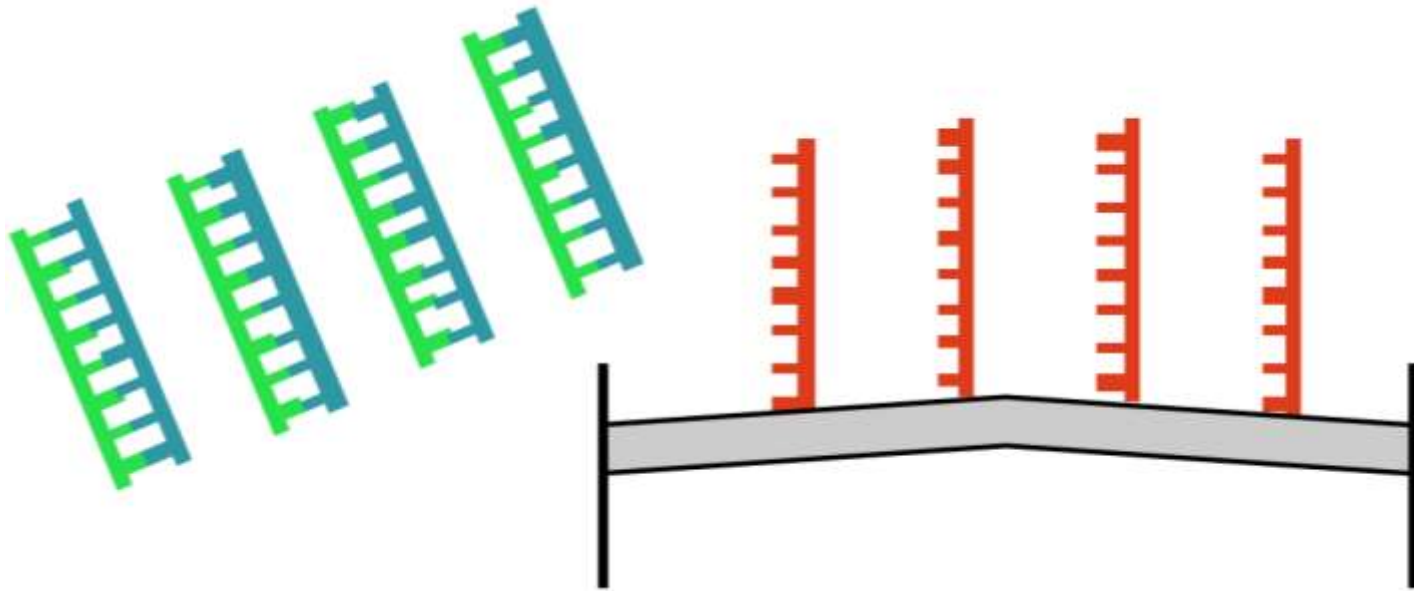
MEMS based DNA microarray



MEMS based DNA microarray

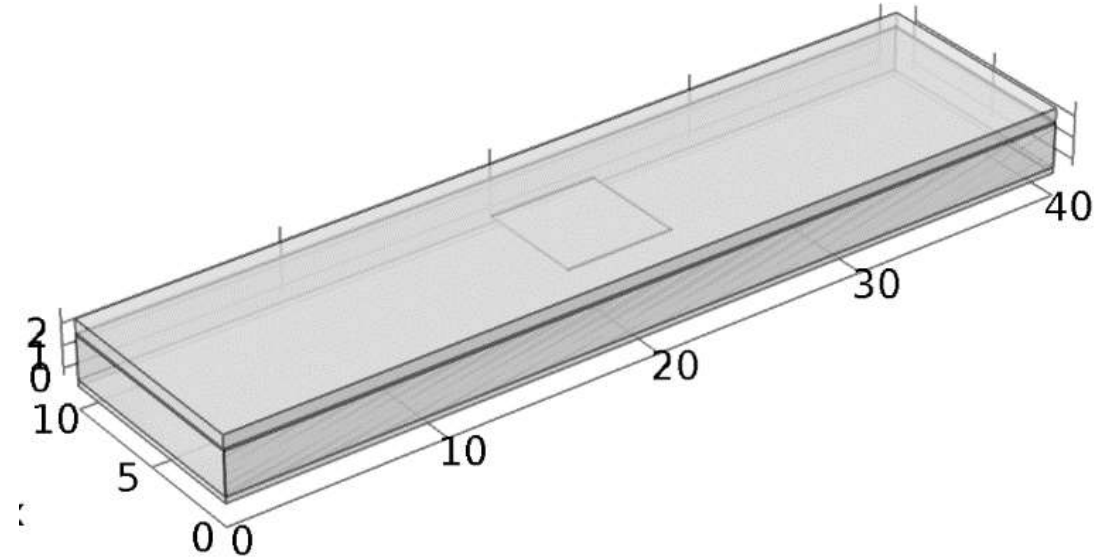


MEMS based DNA microarray



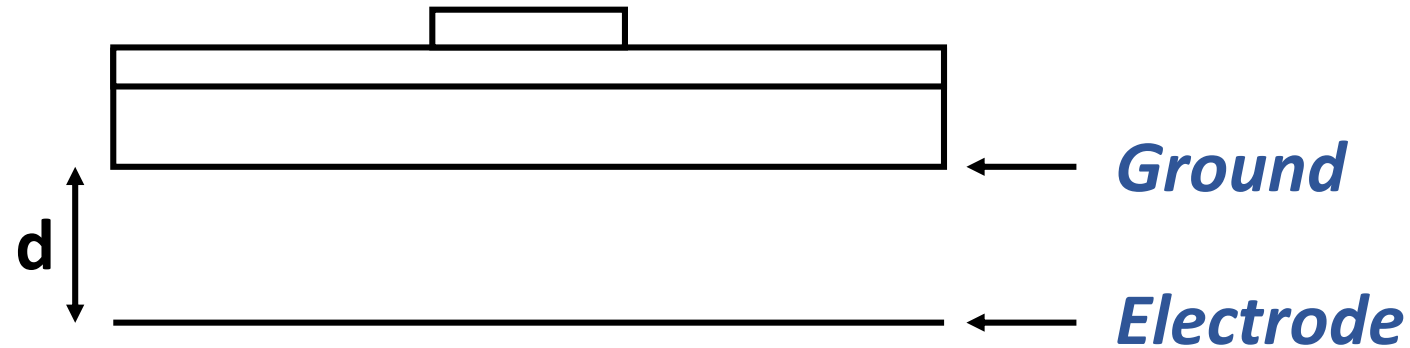
Geometry of the sensor

- Clamped-clamped beam which acts as a resonant mass sensor.
- The base is made of silicon, a piezoelectric layer of PZT atop the base and a patch of silica on the top.
- Capacitive actuation; bottom face grounded and electrode placed a certain distance below it.



Component	Dimensions (l x b x h) (um)
Silicon Base	40 x 10 x 2
Piezoelectric Transducer (PZT)	40 x 10 x 0.1
Silica Patch	5 x 5 x 0.1

Design of Actuation Circuit



DC pre-stressing voltage: 40V
AC actuating voltage: 1V

- When an AC voltage is applied on the electrode, the force on the ground plate varies sinusoidally, hence leading to vibration of the sensor.
- Actuation circuit was designed so that the sensor gives an output of $\sim 100\mu\text{V}$ peak to peak at resonance.

Design of Actuation Circuit

Peak voltage
across sensor



$$V_{sensor} = \left(\frac{d_{31} Y b}{C} \right) \int_l \varepsilon_1 dx$$

$$\varepsilon_1 = \frac{3F}{YbH^2} \left[1 - \frac{x}{l} \right]$$

$$F = \frac{\varepsilon_0 A V_{AC} V_{DC}}{d^2}$$



Plate
separation

Plate separation obtained: 286nm

Damping

- Rayleigh damping model was assumed and damping coefficients were calculated using the following equation:

$$\begin{bmatrix} 1/4\pi f_1 & \pi f_1 \\ 1/4\pi f_2 & \pi f_2 \end{bmatrix} \begin{bmatrix} \alpha \\ \beta \end{bmatrix} = \begin{bmatrix} \xi_1 \\ \xi_2 \end{bmatrix}$$

- $\alpha = 53615.8643 \text{ 1/s}$
- $B = 1.2275\text{e-}11 \text{ s}$

Resonant frequency-mass relation

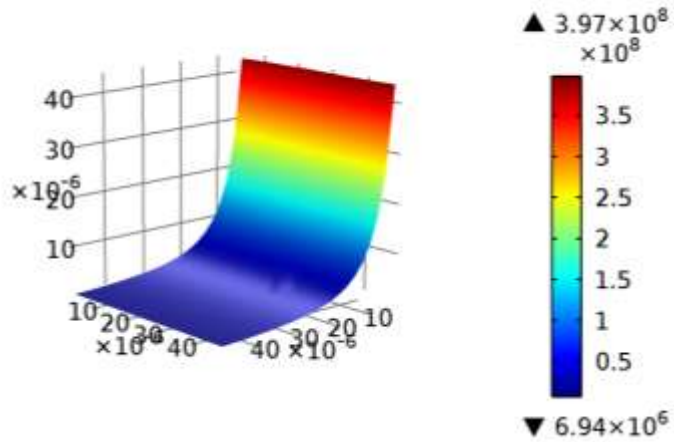
- The new resonance frequency can be found out in terms of the existing resonance frequency and change in mass as:

$$\omega_{n,\Delta m}^2 = \omega_n^2 \left(1 + 2 \frac{\Delta m}{m_0} U_n^2(z_{\Delta m}) \right)^{-1}$$

where $U_n(z) = \sin \left(\frac{n\pi z}{L} \right)$

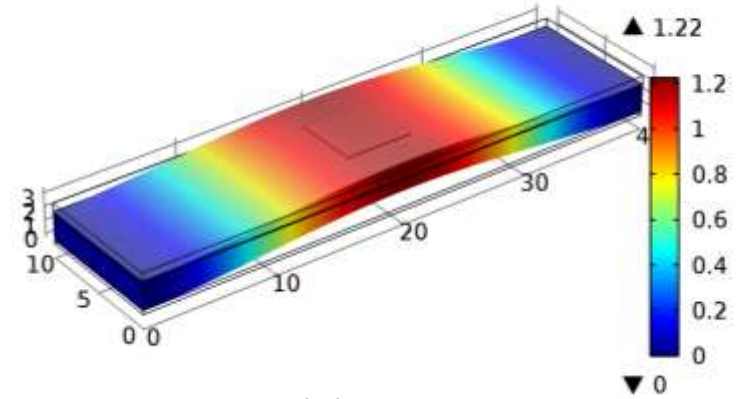
Simulation results

Table Surface: Frequency (1/s), Point: 7



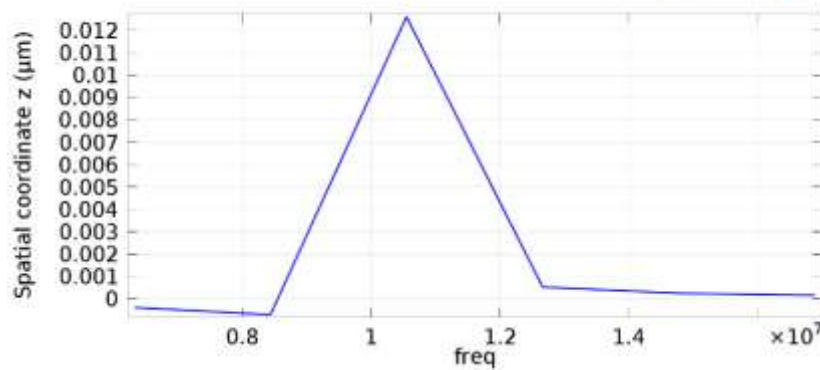
(a)

Eigenfrequency= $1.044793e7+8583.478652i$
Surface: Total displacement (μm)

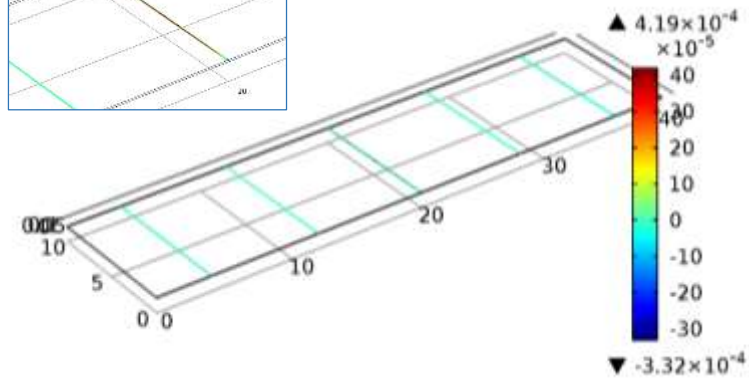


(b)

Point Graph: Spatial coordinate z (μm)

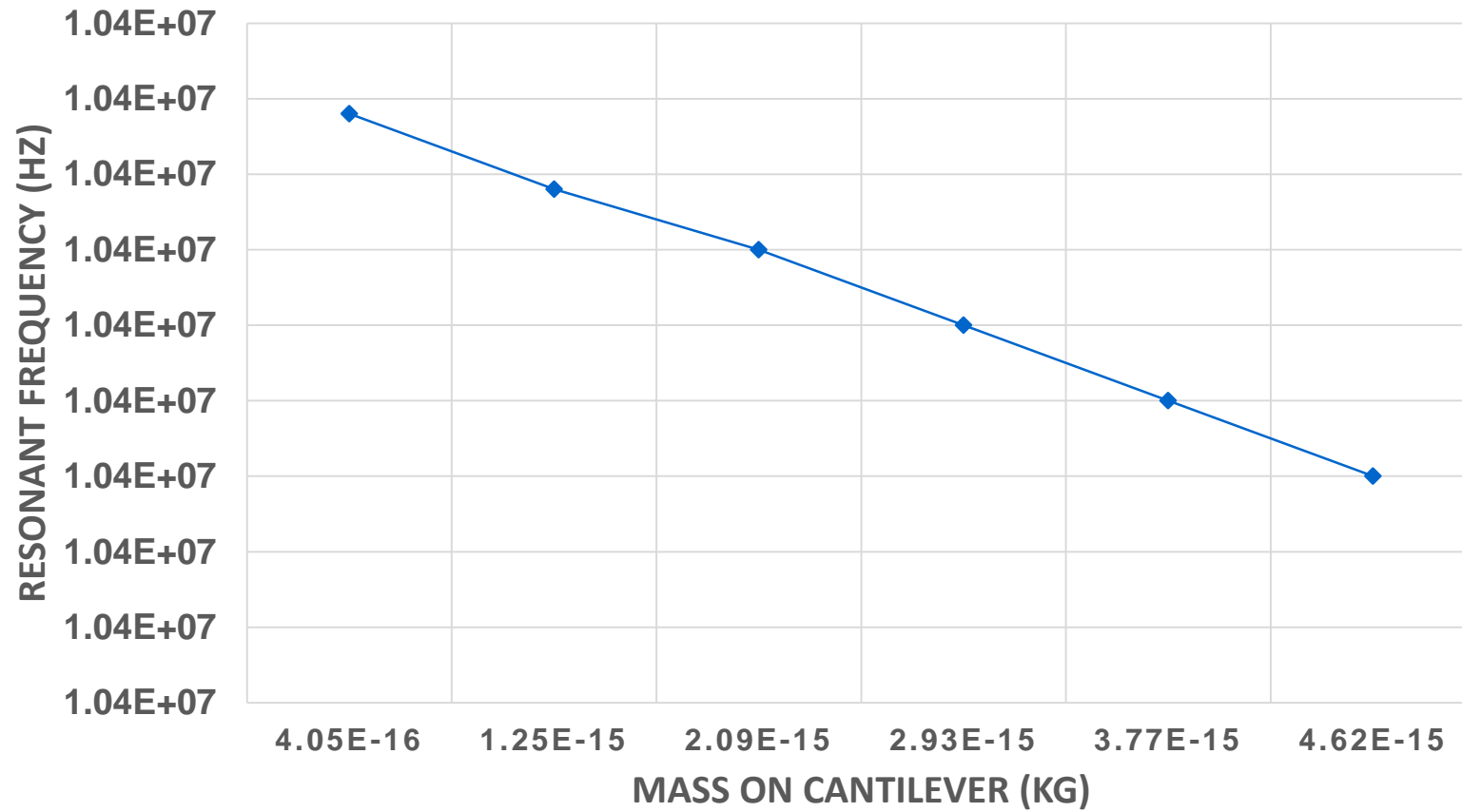


(c)

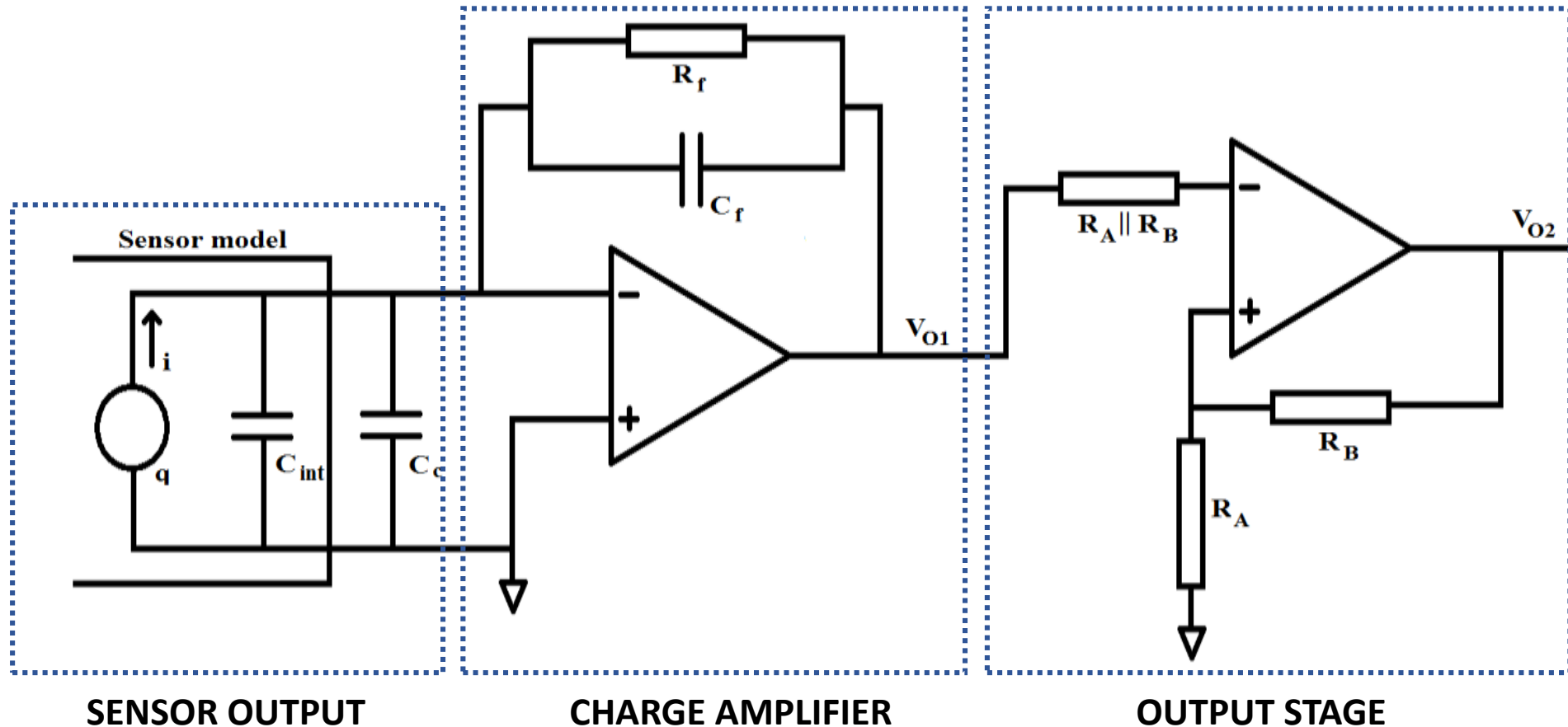


(d)

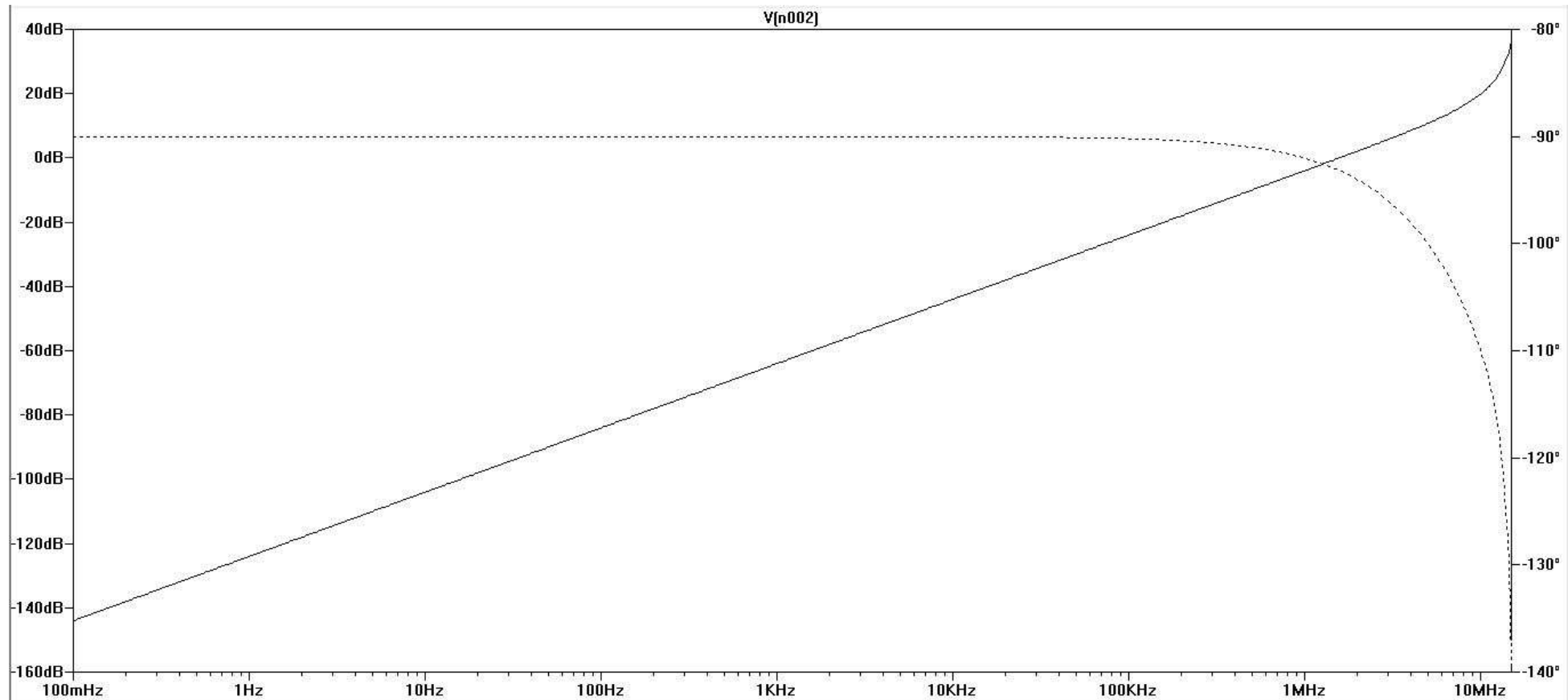
Simulation results



Electronic Circuit



Electronic Circuit Bode plot



Magnitude: 20dB

Phase: -110°

Conclusion

- The study demonstrates simulation of a functioning linear MEMS based DNA sensor with tunable sensitivity.
- We feel that such a device, if implemented successfully would be very useful in making microarray technology available to a wider group of researchers.

Thank You

Questions?